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A Ford
5/28/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/212,726
Filing Date December 15, 1998
Inventor Klaus F. Schuegraf
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Not Known
Attorney's Docket No. MI22-1098
Title: Semiconductor Processing Methods of Chemical Vapor
Depositing SiO₂ on a Substrate

Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

ASSOCIATE POWER OF ATTORNEY

Please recognize Frederick M. Fliegel, Reg. No. 36,138; D. Brent Kenady, Reg. No. 40,045; James E. Lake, Reg. No. 44,854; and Bernard Berman, Reg. No. 37,279; whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as associate attorneys or agents in the above-entitled application.

Date:

5/12/00

David G. Latwesen, Ph.D.

Reg. No. 38,533

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